

Schematic Time Schedule of PSE 2018

Time	Sunday Sep 16, 2018		Monday Sep 17, 2018			Tuesday Sep 18, 2018			Wednesday Sep 19, 2018			Thursday Sep 20, 2018				Friday Sep 21, 2018		
	Room Zugspitze	Room Dreitortspitz	Room Richard- Strauss	Room Zugspitze	Room Olympia	Room Richard- Strauss	Room Zugspitze	Room Olympia	Room Richard- Strauss	Room Zugspitze	Room Olympia	Room Richard- Strauss	Room Zugspitze	Room Olympia	Room Dreitortspitz	Room Richard- Strauss	Room Zugspitze	Room Olympia
08:30 – 09:15			09:00 Official Opening.			Plenary 2			Plenary 4			Plenary 6			Plenary 8			
09:25 – 10:55	Tutorial 1 Fundamentals and trends of plasma surface processing	Tutorial 2 Plasma assisted atomic level processing – PEALD & ALE	Opening Lecture			Session 07 Physical vapour deposition PVD I	Session 08 (Nano-) particles and powders in plasmas	Session 09 Protective and tribological coatings I	Session 12 Physical vapour deposition PVD II	Session 13 Plasma- enhanced chemical vapour deposition (PE)CVD I	Session 14 Protective and tribological coatings III	Session 18 Polymer modification and charac- terization	Session 19 HIPIMS I	Session 20 Other plasma based surface processing technologies	Tutorial 3 (SVC C-337) ITO and alternative TCO: From fundamentals to controlling properties	Session 24 HIPIMS II	Session 25 Analytics of film structures and properties II	Session 26 Optical, electrical and magnetic coatings II
11:05 - 12:55			Session 01 Plasma & ALD	Session 02 Simulation and modeling of growth, structure and properties	Session 03 Biomedical and biological applications I	Industrial Exhibition			Industrial Exhibition			Industrial Exhibition				End of the Conference		
	Lunch break																	
12:55 - 14:20			Lunch break			Lunch break			Lunch break			Lunch break				End of the Conference		
14:20 - 15:05	Tutorial 1	Tutorial 2	Plenary 1			Plenary 3			Plenary 5			Plenary 7						
15:15 - 16:45	continued	continued	Poster Session 1 / Foyer			Session 10 Protective and tribological coatings II	Session 11 Function- alization of surfaces	Industrial Workshop: MEMS in our daily life	Poster Session 3 / Foyer			Poster Session 4 / Foyer			Tutorial 3	continued		
16:45 – 18:55			Session 04 Energy production based coatings I	Session 05 Methods of in-situ process diagnostics	Session 06 Biomedical and biological applications II			Session 15 Energy production based coatings II	Session 16 Plasma- enhanced chemical vapour deposition (PE)CVD II	Session 17 Optical, electrical and magnetic coatings I	Session 21 Atmospheric and in liquids plasma	Session 22 Analytics of film structures and properties I	Session 23 Properties of technological plasmas					
19:00 – 22:00	18:00 - 21:00 Welcome Party / Foyer	19:00 EJC/PISE Meeting inv. Members	19:30 Public Evening Lecture in German			20:30 - 21:30 Poster Session 2 / Foyer		18:45 - 23:00 Industrial Evening / Room Werdenfels		19:00 - 23:00 Conference Dinner, Separate tickets are required!								